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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

DAVID W. SHEEL, ET AL. : EXAMINER: CHEN, BRET P.

SERIAL NO: 10/522,185 :

FILED: AUGUST 26, 2005 : GROUP ART UNIT: 1792

FOR: METHODS FOR PREPARING TITANIA COATINGS BY PLASMA CVD AT ATMOSPHERIC PRESSURE (AS AMENDED)

## REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated January 8, 2009, reconsideration and allowance are respectfully requested in view of the following remarks.

Claims 25 and 27-48 are pending, claims 46-48 having been withdrawn from consideration.

## Withdrawn Claims

For the reasons set forth below, Applicants submit that all pending claims presently subject to examination are in condition for allowance. Because withdrawn claims 46-48 depend from, and thus recite all features of, allowable claims, rejoinder and allowance of claims 46-48 are respectfully requested.